

**Office of Intellectual Property Counsel
3M Innovative Properties Company**

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Date: June 11, 2003

Number of pages including cover sheet: 2

To: Patent and Trademark Office
Examiner M. Estrada
Art Unit 2823

From: Kent S. Kokko, Ph.D
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Remarks: Urgent Acknowledge Reply ASAP Please Comment

RESPONSE TO RESTRICTION REQUIREMENT

Title: "APERTURE MASKS FOR CIRCUIT FABRICATION"

Application Number: 10/076174

Filing Date: February 14, 2002

First Named Inventor: Baude, Paul F.

Attorney Case Number: 57322US002

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PATENT TRADEMARK OFFICE

Patent
Case No.: 57322US002#8/Elect gr
JUN 11 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: BAUDE, PAUL F.

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Application No.: 10/076174

Group Art Unit: 2823

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Filed: February 14, 2002

Examiner: M. Estrada

John H

Title: APERTURE MASKS FOR CIRCUIT FABRICATION

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RESPONSE TO RESTRICTION REQUIREMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF TRANSMISSION

To Fax No.: 703-872-9318
I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent
and Trademark Office on:June 11, 2003
DateHylis H. Froelke
Signed by: Hylis H. Froelke

Dear Sir:

This is in response to the Restriction Requirement mailed May 15, 2003.

RemarksRestriction to one of the following groups of claims was required under 35 U.S.C. Section
121:Group I: Claims 1-7, 21-58, and 65-80, drawn to a method of making a
semiconductor device, classified in Class 438, subclass 401;Group II: Claims 8-13, 17-20, 59-64, and 81-83, drawn to a semiconductor
device, classified in Class 257, subclass 797;Group III: Claims 14-16, drawn to an apparatus, classified in Class 118, subclass
723.

Applicants hereby elect Group I, claims 1-7, 21-58, and 65-80, without traverse.

Date

6/11/03

By:

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